#### **RESEARCH ARTICLE**



### Effect of plasma power on the semiconducting behavior of lowfrequency PECVD $TiO_2$ and nitrogen-doped $TiO_2$ anodic thin coatings: photo-electrochemical studies in a single compartment cell for hydrogen generation by solar water splitting

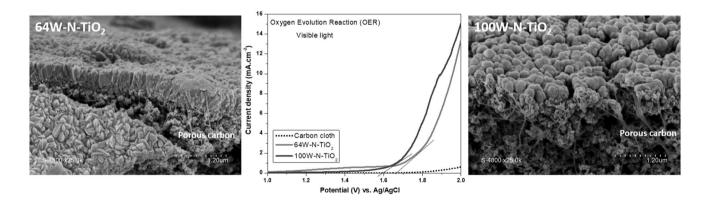
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#### Abstract

Previously optimized anatase and nitrogen-doped anatase  $TiO_2$  coatings have been grown by low-frequency plasma-enhanced chemical vapor deposition (PECVD) on different kinds of substrates at low plasma power (64 W) and high plasma power (100 W) for photo-electrochemical studies. Nitrogen-doped  $TiO_2$  layers exhibit better photoactivity and also higher electronic conductivity under UV and visible irradiations than non-doped materials. The main reason is that nitrogen introduction induces  $TiO_2$  band gap tailoring towards higher wavelengths. In addition, films prepared at low plasma power present a 'typical photo-material' behavior (whose activity depends directly on the presence of light) while layers synthesized at higher plasma power contain an initial conductive phase giving them an activity that exists in the dark yet and can be slightly enhanced by illumination. Such conclusions are prominent in the field of photo-anodic thin films; indeed PECVD could constitute a promising approach for tailoring the efficiency of photo-electrochemical cells for hydrogen production under solar light.

#### **Graphical abstract**



Keywords Anatase · Nitrogen doping · PECVD · Plasma power · Photo-electrochemistry · Hydrogen

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#### **1** Introduction

The 'Solar-to-Hydrogen' approach has been widely discussed over the past twenty years, especially with the increase of the negative side effects derived from the excess usage of fossil fuels [1-4]. In fact, the main reasons behind hydrogen investigation as an alternative green fuel are its availability and its exceptional energetically efficient combustion generating only water as a by-product [5]. The problem remains in the fact that such a compound could not be found naturally as H<sub>2</sub> but is chemically bounded to other elements like carbon or oxygen. For that, energy supply is necessary in order to split H<sub>2</sub> combining products, thus producing hydrogen as a fuel from a primary source.

Many works have been performed in order to find convenient hydrogen primary sources with good gas yields. As a first trial, thermochemical processes have been presented for hydrogen production from fossil fuels. J. Jechura presented the process of H<sub>2</sub> generation from natural gas by steam methane reforming (SMR) [6]. A range of 95-98% hydrogen purity was obtained but, even though the process is cheap, the SMR-integrated systems still require high maintenance. Coal gasification has also been reported in various studies [7-10]. Still such techniques require high-energy initial supplies, they generate carbonated compounds particularly carbon dioxide ( $CO_2$ ) as by-products and the produced  $H_2$  is obtained with low purity percentages. Biological processes, taking advantages of the microorganisms' capacities in biomass digestion for H<sub>2</sub> release, have also been investigated in the field of hydrogen generation [11–13]. Despite the fact that these investigations are very new and present good gas yield perspectives, the processes preparation and manipulation conditions remain delicate and sensitive [14]. Further studies should be done in order to improve many aspects of such processes, including low-cost materials and highefficiency microbes.

The previously cited investigations have been based on compounds that initially do not include hydrogen but whose reaction generates this energetic gas as a by-product. Then, the concept of 'Hydrogen generation by water splitting' emerged from the fact that  $H_2O$ , the most available compound on earth, could be dissociated into its elements, oxygen and hydrogen. For that, water electrolysis using external electrical supply has been studied and optimized under several experimental conditions in order to conclude on the best materials performances [14–18].

In a water-splitting system, oxidation occurs on the anode surface (linked to the positive pole of the external power source) generating oxygen, and reduction occurs on the cathode surface (linked to the negative pole of the external source) generating hydrogen. The most well-known watersplitting experiment, using external light source on semiconductor surface, was performed in 1972 by *Fujishima* and *Honda* [19]. A UV light photo-active anode was used to split water into oxygen-generating protons traveling through the solution to reach the cathode surface. There protonic reduction occurred and hydrogen was produced. This approach was a tremendous discovery that opened many perspectives on further studies about 'photo-electrochemistry' or 'synthetic photo-synthesis' [20, 21]. However, the photo-anode efficiency should still be optimized and enhanced to fill in the major part of the solar spectrum. The semiconductor used in this study was  $TiO_2$  whose behavior is well described in the following theoretical part.

In a previous work by our group aiming at developing anode materials for solar water-splitting systems [22], TiO<sub>2</sub> thin layers with competitive microstructural and photocatalytic properties have been prepared using a one-step low-frequency plasma-enhanced chemical vapor deposition (PECVD) process, operating at temperature as low as 350 °C. Single-oriented pure and N-doped anatase films have been synthesized using titanium isopropoxide (TTIP) as a precursor, and NH<sub>3</sub> as a doping agent. Optimized PECVD conditions have enabled to obtain homogeneous micro-columnar porous thin films with thicknesses close to 500 nm. Depth-profiling XPS analyses have proved the nitrogen incorporation into TiO<sub>2</sub> lattice after ammonia introduction in the deposition chamber. As another proof of N-doping, Raman and XRD peaks shifting have been observed. Such thin films have been demonstrated to be efficient photocatalytic materials whose activity region can be tailored from UV to visible region by adjusting the proportion of doping agent in the plasma phase.

The present work is a sequel to the optimized  $TiO_2$  (nondoped) and N-TiO<sub>2</sub> (nitrogen doped) low-frequency PECVD thin films previously developed [22]. The structural, optical, and photo-electrochemical properties of slightly doped (implementing 5 Pa as NH<sub>3</sub> partial pressure in the PECVD chamber) layers are investigated in the dark, under UV, and under visible light and compared to the non-doped TiO<sub>2</sub> synthesized at two different plasma discharge powers.

#### 2 State-of-art on the photo-electrochemical behavior of semiconductors

The overall water-splitting reaction is summarized as follows:  $H_2O \rightarrow H_2 + \frac{1}{2}O_2$ . For ideal electrolysis systems, for example, those using highly conductive metals as electrodes, a half mole of  $O_2$  and a mole of  $H_2$  are produced per mole of water. However, for systems using semiconductors or organic-based compounds, yield limitations generally appear due to the use of a low conducting electrode [23–25]. Still, water electrolysis requires an external electrical power source in order to drive the reactions.

One interesting approach for water splitting, derived from electrolysis, is photo-electrolysis of water. In such a process, water dissociation into its own elements is induced by solar energy on a single photo-electrode surface. This device eliminates the need for a separate power generator, reducing overall costs and increasing efficiency. The usual suggested hypothesis was the possibility of 'electrodeless' water photo-splitting. *Cohen* explained that water is completely transparent to a certain light range and could never be directly dissociated under energy sources of wavelengths higher than 190 nm. This means that electrode materials, properly responding to common light sources, are required [26]. Semiconductors are widely known for their reaction abilities after absorbing a light source of wavelength smaller than their band gap, i.e., the energy difference between the filled valence band (VB) and the empty conduction band (CB).

When the material absorbs radiations of wavelengths at least corresponding to their band gap energy (according to the formula:  $E_{g} = hc/\lambda$ ,  $E_{g}$  is the band gap energy in eV, h is the Planck constant  $(6.62 \cdot 10^{-34} \text{ J s})$ , c is the light velocity  $(3 \cdot 10^8 \text{ m s}^{-1})$ , and  $\lambda$  is the wavelength in nm; reductive electrons (e<sup>-</sup>) are promoted from the Highest Occupied Molecular Orbital (HOMO) to the lowest unoccupied molecular orbital (LUMO). This generates oxidizing holes (h<sup>+</sup>) in the valence band leading to electron/hole pairs. The limiting photoactivity factor is the lifetime of the electron-hole pairs. Increasing this latter factor leads to a higher material efficiency under light because of enhancement of redox reactions rate. According to literature [27, 28], semiconductors have two different behaviors (p-type or n-type) in contact with a solution depending on the energy edges depletion on the material surface (Fig. 1).

An n-type semiconductor (Fig. 1a) has an electron excess near the conduction band. The level depletion derivative force acts in such a way to transport electrons into the electronic back contact through the external circuit towards the facing counter-electrode (reduction), while holes are preferably emitted into the solution. These holes are able to oxidize species in the electrolyte and the semiconductor behaves as a 'photo-anode.' A p-type semiconductor (Fig. 1b) has a hole excess near the valence band that are transported into the back contact by the derivative force while electrons pass through the solution where they can reduce species in the electrolyte. Thus, such a semiconductor is qualified of a 'photo-cathode.' These behaviors are observed on both intrinsic (non-modified by external species) and extrinsic (modified by metals or chemically doped) semiconductors. The latter explanations are important to understand the electrochemical systems proposed and studied in the literature.

The present work is mainly focused on a configuration in which a light activated photo-anode oxidizes water into oxygen ( $H_2O + 2h^+ \rightarrow 2H^+ + \frac{1}{2}O_2$ ). The generated protons diffuse through the  $H_2SO_4$  electrolyte while the electrons flow through the external circuit. The protons reduction into hydrogen occurs at the glassy carbon electrode surface ( $2H^+$ +  $2e^- \rightarrow H_2$ ). The present work is more a study in the field of photo-water splitting or photo-electrochemical water molecule dissociation.

The choice of semiconductors as electrodes is not random [29]. These materials should have enough large band gaps to split the water molecule into its own elements hydrogen and oxygen. Numerous studies on photo-water splitting have been developed on common semiconductors. The most important point is that the semiconductor band gap edges must fill in the water oxidation/reduction levels which are theoretically 1.23 eV per electron (oxidation) and 0 eV (reduction) (vs. RHE, reversible hydrogen electrode). This is the reason why silicon is limited for hydrogen generation from water even though its band gap could cover a major part of the solar spectrum (1.1 eV-2.4 eV).

Here, a remark should be done considering that confusions occur generally between three concepts in the 'photoactive materials' field. The three concepts are 'photovoltaic,' 'photo-catalysis,' and 'photo-electrochemistry.' In fact, 'photovoltaic' process is converting solar light into electricity. This concept is applied to Solar Cells (SC) manufacture and elaboration [30, 31].

'Photo-catalysis' is more like accelerating a reaction under light effect. Photocatalytic effect is actually applied for organic molecules degradation and water purification using economical activation sources such as natural light [32–34].

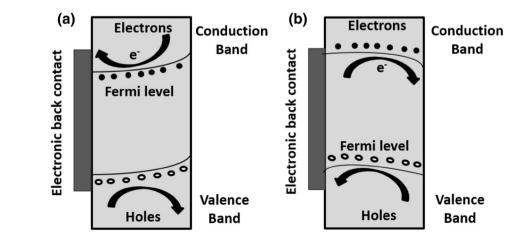


Fig. 1 Schematic representation of intrinsic energy band behaviors of **a** n-type semiconductor and **b** p-type semiconductor 'Photo-electrochemistry' or 'Photo-galvanic' process is the study of complex chemical reactions induced or enhanced by light irradiation [35]. This is the field that interests our study in this paper.

Figure 2 is a schematic representation of possible semiconducting materials with their band edges for water-splitting application (from reference [36]). For hydrogen generation by water splitting, a compromise should be made between a gap energy corresponding to the required light wavelengths domain (ultraviolet, visible, and infrared) and band gap edges well positioned according to the water oxidation/proton reduction redox couples. Taking the example of ZrO<sub>2</sub> band edges, it could easily oxidize water into oxygen and induce hydrogen generation only when irradiated with short wavelengths (for example, 5 eV:  $\lambda \le 250$  nm) situated in the UV range. In the case of silicon (Si), the wavelength absorption domain is enlarged ( $\lambda \leq 1130$  nm) but this material could not be used to produce hydrogen by water splitting due to its valence band edge situated above the  $O_2/H_2O$ oxidation energy level.

In the present work,  $\text{TiO}_2$  has been used as a photo-anode semiconductor. As it can be noticed in Fig. 2, titanium dioxide presents good valence band position relatively to water oxidation redox couple and it has an average gap value ( $\lambda \leq 414$  nm).

#### 3 Experimental section

#### 3.1 Pure and Nitrogen-doped anodic layers synthesis procedure

Both  $TiO_2$  and N-TiO\_2 layers were deposited by a low-frequency PECVD process according to the procedure previously

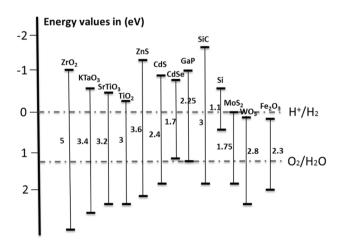


Fig. 2 Band gap energy edge position according to water oxidation/ proton reduction redox couples for thirteen common semiconductors [36]

described and optimized in a paper by our group [22]. The TiO<sub>2</sub> chemical precursor is Titanium Tetra-isopropoxide TTIP (purity  $\geq$  97%) from Sigma Aldrich. The doping agent is anhydrous ammonia NH<sub>3</sub> supplied by a gas cylinder from Gazechim®. The partial pressures of vapors and gases in the PECVD chamber during the deposition step are 22.5 Pa for Ar + TTIP (Ar being used as a carrier gas), 17 Pa for  $O_2$  ( $O_2$ being used as an oxidizing agent), and 5 Pa for NH<sub>3</sub> (added in the plasma reactor for doping purpose). Two sample series were prepared: the series at low plasma discharge power (64 W) and the series at high plasma discharge power (100 W). 64 W has been chosen as the same low input power as that optimized in a previous study by our group dedicated to TiO<sub>2</sub> deposition by radio-frequency PECVD [37] and 100 W has been selected as the highest input power delivered by the lowfrequency generator used in this study. The deposition time was 20 min and the deposition temperature was 350 °C for all the samples, in a one-step process.

In this paper,  $TiO_2$  and  $N-TiO_2$  films prepared at 64 W and 100 W will be named 64W-TiO<sub>2</sub>, 64W-N-TiO<sub>2</sub>, 100W-TiO<sub>2</sub>, and 100W-N-TiO<sub>2</sub>, respectively.

Three different kinds of supports were used: single crystalline silicon (100) (from the Monsanto Electronic Materials Company, Boron-doped type p-Si (100), resistivity:  $1-50 \Omega$ ), nickel foil (purity  $\geq$  99.9%) for structural characterizations, and a porous carbon substrate (commercial E-Tek® conductive black cloth for electrochemical characterizations).

### 3.2 Morphological and structural characterization techniques

In the previous work by our group [22], the morphology of plasma layers had been observed for materials deposited on Si substrates. Here, the surfaces and cross sections morphologies were investigated on layers deposited on Ni (for crystal morphology observation) and E-Tek® (for electrochemical functional studies) supports by scanning electron microscopy (SEM) using a *Hitachi S4800* microscope.

The density of plasma layers deposited on Si was determined by X-ray reflectometry (XRR) using a *Siemens/Bruker D5000 with a CuK<sub>a</sub> source* ( $\lambda$ =1.54056 Å). Manipulating with the same Si support, *ESCALAB 250* from *Thermo Electron* was used for XPS depth profile correlations and a *GES5E* spectroscopic ellipsometer from Semilab (wavelength from 250 nm to 1000 nm, incidence angle of 70°) was used to evaluate the layer refractive index and optical properties. The ellipsometry data were simulated and fitted using *Winelli2*® software.

#### 3.3 Electrochemical characterizations in a single compartment photo-electrochemical cell

The electrochemical characterizations of plasma-layered electrodes were performed in a single compartment Teflon® cell equipped with a 27-mm diameter transparent quartz window (Fig. 3). A three electrode configuration was implemented involving: a plasma layer deposited on an E-Tek® carbon cloth (in the form of a disc of 10 mm diameter making a constant surface of 0.785 cm<sup>2</sup>) as the photoanode (working electrode), a commercial glassy carbon material (0.7 cm x 2 cm) as the cathode (counter-electrode), and a commercial Ag/AgCl (3 M KCl) from *SI Analytics*® (0.197 V vs. RHE) as the reference electrode.

The three electrodes were immersed in a 0.5 M H<sub>2</sub>SO<sub>4</sub> liquid electrolyte solution (prepared from a 100% H<sub>2</sub>SO<sub>4</sub> solution from *Merck Millipore*® in 18 MΩ pure *MilliQ*® water from *Millipore*®). In order to ensure good electron collecting through the external circuit, both photo-anode and cathode were tightly connected to gold wires (Goodfellow  $\geq$  99.9% from *Sigma Aldrich*®) that were not immersed in the electrolyte solution in order to avoid metallic interference response. Two different irradiation sources were used: a 75 W ( $\lambda$ = 355 nm) [37] from *Eurosolar*® and a 150 W filtered ( $\lambda \geq$  400 nm) from *Van Cliff* lamps for UV and visible, respectively. It should be mentioned that since the carbon cloth is not transparent and by that it will absorb the light before reaching the active layer, the plasma film was facing

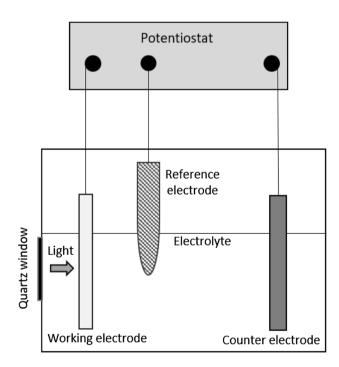


Fig. 3 Schematic representation of the single compartment photoelectrochemical cell

the lamp irradiation which was focused and adjusted to the cell quartz window in order to maintain constant irradiation in UV and visible for all the samples.

The whole cell was covered by aluminum foil during the illumination experiments to concentrate the light and to avoid room light interference when performing experiments in the dark. Lastly, before each electrochemical test, the electrolyte solution was degassed by pure argon bubbling for 40 min in order to get rid of the dissolved oxygen.

Impedance measurements were performed in order to evaluate the  $\text{TiO}_2$  and the N-TiO<sub>2</sub> intrinsic electronic resistance and the electrode/electrolyte interface properties. Electrochemical Impedance Spectroscopy (EIS) was performed with a *Solartron*® *SI 1260* frequency analyzer (in a range of 0.02 Hz–10<sup>5</sup> Hz with 10 mV AC amplitude). Both *ZPlot*® and *ZView*® softwares were used to record and fit the experimental data.

In order to investigate the n-type semiconductor behavior and the Oxygen Evolution Reaction (OER), the Open Circuit Voltage (OCV), the Cyclic Voltammetry (CV) at 5 mV s<sup>-1</sup>, and the Linear Voltammetry (LV) at 1 mV s<sup>-1</sup> were, respectively, recorded using a *Solartron*® *SI* 1287 galvanostat–potentiostat. The softwares are *CorrWare* 2® for experimental data recording and *CorrView*® for text files collecting.

#### 4 Results and discussions

#### 4.1 Coatings morphology and thickness observations by SEM

In a previous paper by our group [22], SEM characterization of films on Si substrate had enabled to observe micro-columnar porous thin films with thicknesses close to 500 nm. Nevertheless, the crystal morphology could not be precisely depicted. This is the reason why dense nickel foils were used as supports in the present study (Fig. 4).

Figure 4a shows the  $64W-TiO_2$  sample on Ni, the (101) facet orientation is clearly observed. Moreover, a dense thin layer starts to grow at the bottom of the upper layer for such a plasma power, while the  $100W-TiO_2$  layer (Fig. 4b) shows a homogeneous columnar growth throughout the thickness. The latter layers expose 'flower-like' (101) facets while sharper and defined ones are exposed for the  $64W-TiO_2$  layers. In Fig. 4c, d, respectively, corresponding to the  $64W-N-TiO_2$  and  $100W-N-TiO_2$  doped samples, the (101) facets coverage with a nitride shell is obviously observed as cited in the works of *Cho et al.* [38].

The coverage is more observed in the case of layers prepared at 64 W since the exposed facets are dense unlike the 'flower-like' facets of the layers synthesized at 100 W where the nitrided shell could have covered the scattered surface.

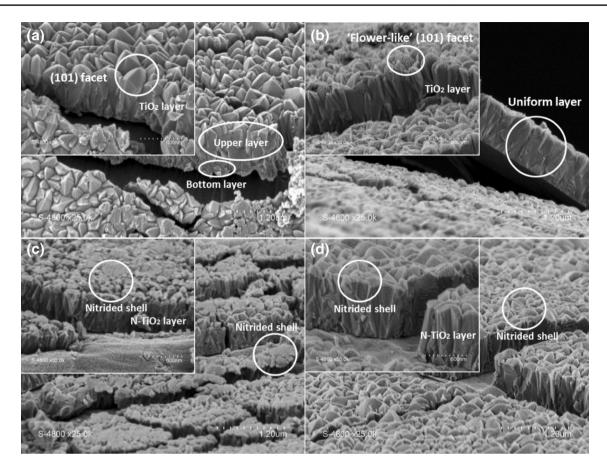


Fig. 4 Surface and cross section SEM images of a 64W-TiO<sub>2</sub>, b 100W-TiO<sub>2</sub>, c 64W-N-TiO<sub>2</sub>, and d 100W-N-TiO<sub>2</sub> deposited on nickel foil

The  $TiO_2$  and N– $TiO_2$  low-frequency PECVD thin layers deposited on porous carbon (E-Tek®) are presented in Fig. 5. The 'flower-like' morphology of the crystallized coatings depicted on Ni support could be noticed on the carbon cloth surface. The nitrogen doping seems to induce local agglomeration on some surface points. The crystallite edges become a little thicker after nitration.

Table 1 presents the films thicknesses measured by SEM cross section on nickel foil and E-Tek® cloth for the same deposition time of 20 min.

The first observation is that increasing the plasma power from 64 W to 100 W increases the growth rate since higher thicknesses were measured on both substrates at 100 W. The second observation is that lower thicknesses values were obtained on E-Tek® cloth. This could be due either to a hidden thickness by crystals grown inside the cloth or to the fact that metallic nucleation sites on nickel foil are highly activated by plasma and accelerated by the layer surface growth. The third observation is that the growth rate is slowed by doping process, especially on Ni support. In fact, when adding NH<sub>3</sub> gas into the plasma phase, reactive species reactions are more favored into the plasma gaseous volume more than on substrate surface. This leads to a competition between species–species (volume) collisions and species-solid (substrate) interactions [39]. This process leads to lower growth rate.

#### 4.2 Coatings refractive index, growth simulation, and Nitrogen composition

The layers refractive index and growth simulation were analyzed by ellipsometry measurements on Si wafer. This support is the most suitable for this kind of analysis since it is dense and reflective so the layer–substrate interface could be easily detected by the incident light beam.

According to the literature, the theoretical refractive index for crystalline dense anatase is 2.5-2.6 [40, 41]. The RI of TiO<sub>2</sub> thin films could be affected by the layer microstructure including lattice modification, porosity, and crystalline amount [42].

In our case, the layer was analyzed at atmospheric pressure and its microstructure was fitted on the wavelength range 380 nm-1 µm using the stack model presented in Fig. 6.

The Cauchy optical behavior of dielectric materials well fits the bulk  $TiO_2$  material on this range. A diffusion layer,

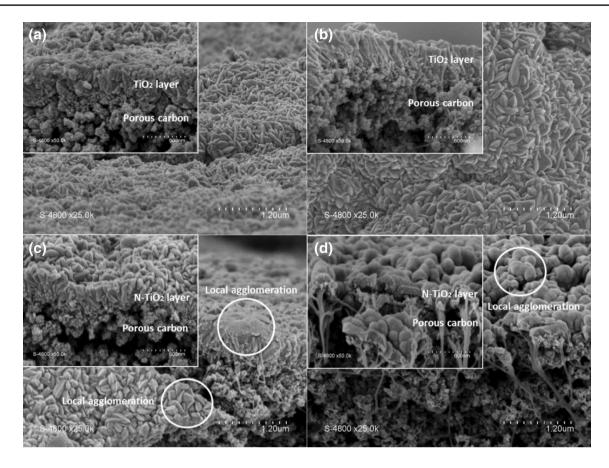


Fig. 5 Surface and cross section SEM images of a 64W-TiO<sub>2</sub>, b 100W-TiO<sub>2</sub>, c 64W-N-TiO<sub>2</sub>, and d 100W-N-TiO<sub>2</sub> deposited on an E-Tek® carbon cloth

 Table 1
 Non-doped and doped samples thickness measurements on nickel foil and on an E-Tek® carbon cloth

Sample	Thickness on Nickel (nm)	Thickness on Carbon (nm)
64W–TiO <sub>2</sub>	650	369
64W–N–TiO <sub>2</sub>	460	305
100W-TiO <sub>2</sub>	735	396
$100W-N-TiO_2$	675	365

based on the Bruggeman effective medium approximation of the underlying bulk  $\text{TiO}_2$  mixed with the upper air, was used to simulate the top surface roughness of the films which could play a significant role in the interface processes in contact with the electrolyte.

**Fig. 6**  $\text{TiO}_2$  and N-TiO<sub>2</sub> layer Cauchy simulation by ellipsometry on Si (100) wafer

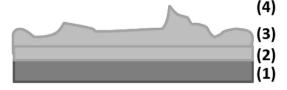


Table 2 shows the layer microstructure composition with the corresponding refractive index given at 633 nm (RI).

It can be noticed that all the correlation factors are above 0.986 which is an indication of a good layer microstructure fitting with the Cauchy behavior and the chosen model of Fig. 6. As a microstructure correlation with XPS atomic percentages, the atmospheric nitrogen adsorbed atomic percentages have been found to be 0.55 at% at 400.14 eV on the non-doped 64 W and 0.79 at% at 399.93 eV on the non-doped 100 W layers. This adsorbed nitrogen is generally located in the diffusion layer. For almost the same diffusion percentages at non-doped 64 W (5%) and 100 W (4%), the RI lowering from 1.9794 (64 W) to 1.5937 (100 W) is mainly due to the disorder induced by N<sub>2</sub> surface adsorption. Meanwhile, the non-doped TiO<sub>2</sub> bulk keeps almost a constant RI for both powers as an

- (1) Si (100) substrate
- (2) Bulk TiO<sub>2</sub>
- (3) Diffusion layer
- (4) Atmosphere

Bulk Top RI Correlation Sample % of the full thick-RI factor (fit on ness 380-1000 nm) Bulk Diffusion 64W-TiO<sub>2</sub> 95.0 5.0 2.390 1.979 0.986 64W-N-TiO<sub>2</sub> 99.9 0.1 1.922 1.880 0.995 100W-TiO<sub>2</sub> 96.0 4.0 2.318 1.594 0.990 100W-N-97.0 3.0 2.469 1.621 0.993 TiO<sub>2</sub>

**Table 2**Layer microstructure composition and optical properties asdetermined by ellipsometry on Si (100)

indication of lattice conservation. This RI is lower than the theoretical anatase one even though the layer has been proved to be well crystallized at 350 °C [22]. This fact is probably due to the layer porosity ( $n_{air} = 1 < n_{anatase}$ , where n is the refractive index of the medium) so that a porous layer introduces more air since the analysis is performed under atmospheric surrounding. This will be discussed in the XRR analysis.

For the N-doped  $\text{TiO}_2$  samples at 64 W and 100 W, the optical correlation with the XPS results is deduced from Table 3.

The percentage values in Table 3 represent the mean value of the N1s atomic contents along the thin film from the surface (0 s etching time) to 2110s etching time. Both N-doped 64 W and 100 W layers exhibit mostly the same insertion and adsorbed nitrogen atomic percentages, so this is not the limiting factor in that case. The difference is observed in the substitutional (Ti-N) nitrogen amount. As a correlation with the RI values, it is obvious that increasing the substitutional N-doping induces a bulk RI decrease (1.9219 for 64 W and 2.4693 for 100 W).

Even though the insertion and surface adsorption percentages are similar in both plasma powers, the diffusion RI decrease from 1.8803 (64 W) to 1.6205 (100 W) is explained by the higher diffusion concentration at 100 W.

These microstructure differences between two layers synthesized at two different plasma powers are responsible of the behavior difference at the electrode–electrolyte interface presented in the electrochemical results.

Table 3	N1s atomic	percentages	deduced	by	depth	profiles	XPS	for
the nitrogen-doped 64 W and 100 W TiO <sub>2</sub>								

Sample	Substitutional N (396 eV)	Insertion and surface adsorption N (398– 402 eV)
64W–N–TiO <sub>2</sub>	1.58%	0.98%
$100W-N-TiO_2$	0.59%	1.02%

#### 4.3 Coatings density

The theoretical density reported for anatase is 3.82–3.97 g. cm<sup>-3</sup> [43]. Using XRR data, a thin layer mass density  $\rho_m$  is calculated according to the formula 1 [44]:

$$\rho_{\rm m} = \left(\pi \Theta_{\rm c}^2 / \lambda^2 N_{\rm A} r_0\right) \left(\sum A_i C_i / \sum Z_i C_i\right). \tag{1}$$

 $\Theta_c$  is the critical angle (converted from degrees to radians) deduced from the minimum of the first derivative of the intensity versus angle plot,  $\lambda = 1.54056$  Å (of the incident beam),  $N_A$  is the Avogadro number ( $6.022 \cdot 10^{23}$  e.mol<sup>-1</sup>),  $r_0 = 0.0000282$  Å is the standard electron radius,  $A_i$  is the element molar mass,  $C_i$  is the element atomicity, and  $Z_i$  is the element atomic number.

$$\sum A_{i}C_{i} / \sum Z_{i}C_{i} = (1 \cdot A_{Ti} + 2 \cdot A_{O}) / (1 \cdot Z_{Ti} + 2 \cdot Z_{O})$$
  
= 2.105 for TiO<sub>2</sub>. (2)

The first derivative plots as a function of the angle for the non-doped and the doped 64 W and 100 W layers on Si (100) are plotted in Fig. 7.

For the non-doped 64 W and 100 W layers,  $\Theta_c$  were found to be 0.25579° and 0.2285° (the mean value of the two minima on the curve), respectively. Using the formula cited previously, the calculated 64W–TiO<sub>2</sub> density is 3.27 g cm<sup>-3</sup> and the calculated 100W–TiO<sub>2</sub> density is 2.61 g cm<sup>-3</sup>. The two values are lower than the theoretical 3.82–3.97 g cm<sup>-3</sup> as an indication of porosity existence. The 100W–TiO<sub>2</sub> exhibits more porosity than the 64W–TiO<sub>2</sub> which is in good agreement with the RI values. This could also be linked to the SEM observations shown in Fig. 4a and b where the

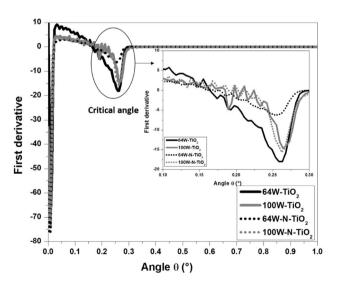


Fig. 7 XRR first derivative plot of the non-doped and N-doped 64 W and 100 W layers deposited on reflective Si (100)

 $100W-TiO_2$  surface presents a 'flower-like' porous morphology that has a low RI of 1.5937 due to atmosphere inclusion.

The N-doped TiO<sub>2</sub> molecular formula is TiO<sub>2-x</sub>N<sub>x</sub> since some Oxygen atoms are substituted by Nitrogen. According to that, the multiplying factor  $\sum A_i C_i / \sum Z_i C_i$  would be equal to the following:

$$(1 \cdot A_{\text{Ti}} + (2 - x) \cdot A_{\text{O}} + x \cdot A_{\text{N}}) / (1 \cdot Z_{\text{Ti}} + (2 - x) \cdot Z_{\text{O}} + x \cdot Z_{\text{N}}) = (48 + 32(2 - x) + 14x) / (48 + 16(2 - x) + 7x).$$
(3)

The critical angles were found to be  $0.24761^{\circ}$  and  $0.26156^{\circ}$ , respectively, for  $64W-N-TiO_2$  and  $100W-N-TiO_2$ . Not considering the multiplying factor, the calculated values of the coating density are 1.46 mol cm<sup>-3</sup> and 1.62 mol cm<sup>-3</sup>, respectively, for  $64W-N-TiO_2$  and  $100W-N-TiO_2$ . Then, the multiplying factor converts the unit from mol cm<sup>-3</sup> to g.cm<sup>-3</sup>.

The multiplying factor development leads to the following simplified ratio: (112 - 18x)/(80 - 9x). According to XPS results,  $x_{64} > x_{100}$  (x is the number of substituted oxygen, 64 and 100 refer to the plasma powers of 64 W and 100 W) since more oxygen atoms are substituted at 64 W. So:

$$112 - 18x_{64} < 112 - 18x_{100} \\ 80 - 9x_{64} < 80 - 9x_{100}$$

Following this mathematical procedure, the multiplying factor at 64 W is lower than the one at 100 W. This result leads to a higher density for the  $100W-N-TiO_2$ . This is also in good agreement with the optical RI values that are higher at 100 W (doped) than at 64 W (doped) as an experimental proof of the higher lattice modification at low plasma power.

In fact, according to some references [45, 46], the variation in the nitrogen bulk amount is plasma power dependent. This is due to the nitrogen form present in the gaseous phase and which is directly related to the electronic density (the plasma power). The NH<sub>3</sub> dissociation reaction in plasma phase has been well reported in reference [46]. It has been demonstrated that, at the same chamber total pressure (which is the case for both doped samples), NH<sub>3</sub> requires little plasma power to dissociate. Thus, the N<sup>+</sup> species intensity is higher in the low plasma power ranges and then reaches an almost steady state where N<sup>+</sup> species intensity increases slightly up to 150 W. This explains why the substitutional N-doping is more pronounced at 64 W and leads to optical and microstructural modifications. At 100 W, the bulk microstructure is less affected by nitrogen substitution while the surface state modification seems to be more expressed.

## 4.4 n-Type semiconducting behavior by OCV investigation

The definition of OCV of a photo-electrochemical system is the equilibrium potential without applying any external current. According to reference [47], when the semiconductor surface is in contact with the liquid electrolyte, a junction is formed. The latter one, for a n-type semiconductor surface, is represented in Fig. 8.

In real photo-electrochemistry conditions (Fig. 8a), and in case of a n-type semiconductor (like reported for  $\text{TiO}_2$ ), the light irradiation induces electron-hole separation and the added external bias voltage plays the role of the derivative force that conducts the electrons through the external circuit towards the cathode (reduction site) and the holes to the anode surface (electrolyte molecules oxidation).

At OCV conditions (equilibrium state where no current is added in Fig. 8b), when the supposed n-type semiconductor

#### (a) (b) Reality (Light + Electricity) Simulation (Equilibrium state) Electrons Conduction Electrons band Semiconductor layer ermi level Electrolyte Flectronic redox potential Charge Electrolyte back contact molecules seperation 0000 Semiconductor Valence substrate Holes band

Fig. 8 Electrode surface-electrolyte junction **a** real photo-electrochemistry and **b** simulated at Open Circuit Potential for a n-type semiconductor schematic representations

is irradiated, electron-hole separation occurs. Since there is no derivative force to conduct the electrons through the external circuit, these species in the depletion region migrate to the electrode surface and from there to the electrolyte [48]. Thus, under irradiation, the n-type semiconductor Fermi level shifts to lower energy levels towards the electrolyte redox potential. According to reference [49], the OCV (defined as an electrical field) is given by the following equation:

$$eV_{\rm oc} = E_{\rm i(Fermi)} - E_{\rm eq(vs. electrolyte redox potential)},$$
 (4)

where *e* is the elementary charge,  $V_{\rm oc}$  is the OCV,  $E_{\rm i(Fermi)}$  is the Fermi energy level, and  $E_{\rm eq}$  is the maximum level lowering when the anode is in contact with the electrolyte.

When the light is switched on,  $E_{\text{Fermi}}$  gets closer to  $E_{\text{electrolyte}}$  and  $V_{\text{oc}}$  drops (since *e*, the elementary charge, is a constant). When the light is switched off, a relaxation phenomenon occurs and the  $V_{\text{oc}}$  increases again.

The OCV of the pure and doped  $TiO_2$  layers were evaluated under UV and visible irradiation for 800 s. The results are presented in Fig. 9.

It is clear that the four layers exhibit a n-type semiconducting behavior since the OCV increases when the light is switched off and decreases again under illumination.

For the pure 64 W and 100 W TiO<sub>2</sub> layers (Fig. 9a, b), the  $V_{oc}$  is lower in the UV light than in the visible light. This is an indication that the Fermi level of the materials is closer to the electrolyte redox potential in UV. This conclusion is logical since the non-doped TiO<sub>2</sub> absorbs the radiations at least corresponding to its gap in the UV.

The initial  $V_{oc}$  decrease during the first 100 s of illumination is another proof of UV light absorbance. However, the  $V_{oc}$  remains mostly stable under visible light as an indication that the Fermi level is not affected under visible light illumination for pure samples.

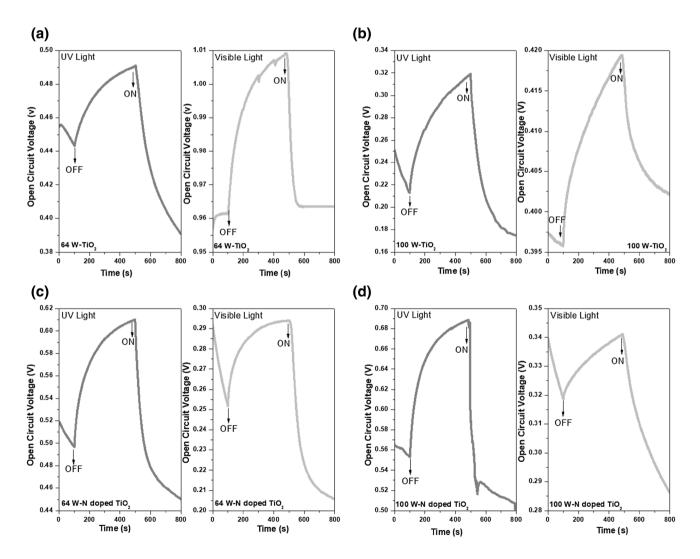


Fig. 9 OCV measurements under UV and visible light for a 64W–TiO<sub>2</sub>, b 100W–TiO<sub>2</sub>, c 64W–N–TiO<sub>2</sub>, and d 100W–N–TiO<sub>2</sub> deposited on E-Tek®

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The remarkable point here is that the  $V_{oc}$  drop when switching on the UV light again at 500 s is fast and reaches a steady state at 700 s for the 100W–TiO<sub>2</sub> while it is slower and is still decreasing at 800 s for the 64W–TiO<sub>2</sub>. This means that the electron–hole pairs are instantly generated under UV illumination in the case of 100 W–TiO<sub>2</sub>.

The  $V_{\rm oc}$  reversibility under visible light has to be discussed for the 64 W and 100 W pure TiO<sub>2</sub> (Fig. 9a, b, light gray plots). When the lamp is switched on at 500 s, the V<sub>oc</sub> drops quickly to its initial value in the case of 64 W (reversible drop) while it decreases slowly and to a higher V<sub>oc</sub> value in the case of 100 W. This phenomenon is explained in Fig. 10.

Correlating the  $V_{\rm oc}$  variations to the surface morphology and optical properties as determined in Sect. 4.2, some surface electron trap seems to exist in the 100W-TiO<sub>2</sub>. In fact, several experimental observations prove this hypothesis. The atmospheric  $N_2$  adsorption is higher at 100 W (0.79%) than at 64 W (0.55%) as reported in XPS analysis. Moreover, the adsorbed N at 100 W is located at a lower binding energy (399.93 eV) than at 64 W (400.14 eV). In addition to that, the 'flower-like' surface observed in the case of  $100W-TiO_2$ seems to play a significant role in the material behavior at the electrode-electrolyte interface. The conclusion from Fig. 10 for the visible light non-reversibility of the  $V_{oc}$  for  $100W-TiO_2$  is that, under the first 100 s irradiation, the value is mainly stable. Switching off the light induces some state relaxation but when the light is switched on again, some electrons, still trapped in the surface state from the first 100 s illumination, limit the  $V_{oc}$  decrease to its initial value.

Similar explanations could be presented in the case of the nitrogen-doped TiO<sub>2</sub> layers (Fig. 9c, d). The  $V_{oc}$  initial values under visible light are lower than under UV as a proof of the doping role in the charge separation enhancement in the visible range. Nitrogen doping creates N1s trap levels which leads to a decrease of the gap energy. Thus, the initial Fermi level is closer to the electrolyte redox potential and the  $V_{oc}$  shifts to lower values. More N1s levels are generated in the band gap of the doped 64 W which lowers the  $V_{oc}$  in both UV and visible light compared to the same layer synthesized at 100 W. These levels also play the role of electron traps so

that it could be seen that the  $V_{\rm oc}$  stabilizes better in the case of the 64 W layers.

#### 4.5 Electrode–electrolyte interface by EIS and correlation with I–V curves by CV

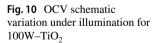
The electrode–electrolyte interface has been studied in the dark, in UV and in visible light by EIS in the conditions previously mentioned in Sect. 3.3. The results are presented in Fig. 11.

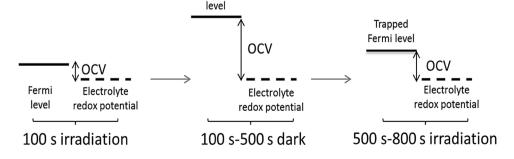
The decrease of the charge transfer resistance  $(R_{ct})$  by the doping process is obvious by the scale lowering from the non-doped to the doped samples.

It could be noticed that no  $R_{ct}$  modification occurred under visible light for the non-doped samples at both 64 W and 100 W. This is an indication that the charge transfer at the electrode–electrolyte is not affected by this wavelength range (> 400 nm) which is logical due to the band gap of both materials. In addition, the resistances of the layers deposited at 100 W are slightly lower than those of the films prepared at 64 W revealing a more intrinsic conductive microstructure at higher plasma power. Under UV light, the resistances decrease remarkably in the case of both plasma powers. This result is in good agreement with both materials band gap and is also coherent with the previous observation since the R<sub>ct</sub> at 100 W decreases more than at 64 W revealing another time the 100 W layer more conductive intrinsic properties.

For the 64W–N–TiO<sub>2</sub>, it could be observed that  $R_{ct}$  decreases remarkably from the dark to UV. A good decrease is also observed under visible light as an indication of charge separation and mobility under this wavelength range (> 400 nm). In parallel, for 100 W–N–TiO<sub>2</sub>, the  $R_{ct}$  decrease under UV light is almost not observed while it decreases under visible light. This means that the charge separation and mobility are better under visible light than under UV light.

The explanation of such differences is reported in the anodic CV curves (at slow scan rate of 5 mV s<sup>-1</sup>) and presented in Fig. 12.





Initial Fermi

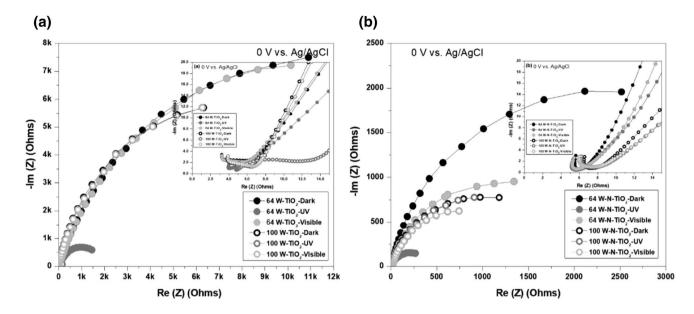


Fig. 11 EIS spectra at 0 V vs. the Ag/AgCl reference electrode of the 64 W and 100 W layers on porous carbon in the dark, in UV and in visible light for the **a** non-doped  $TiO_2$  layers and **b** N-TiO\_2 layers

Figure 12a, c reveals obviously the semiconducting behavior of the 64 W non-doped and N-doped TiO<sub>2</sub> on porous carbon. In the dark, no current was measured for these two layers. In the case of the 64 W-TiO<sub>2</sub> layer (Fig. 12a), under UV light, the photo-current remarkably increased and the redox reaction peaks (anodic  $I_{pa}$  and cathodic  $I_{pc}$ ) are displayed. The positive peak is attributed to the oxidation of Ti<sup>3+</sup> appearing under UV illumination  $(Ti^{3+} \rightarrow Ti^{4+} + 1e^{-})$  while the negative peak corresponds to the reduction of the generated Ti<sup>4+</sup> species  $(Ti^{4+}+1e^- \rightarrow Ti^{3+})$  [50]. Moreover, both peaks (anodic E<sub>pa</sub> and cathodic  $E_{\rm nc}$  around 0.35 V–0.4 V) are close enough to consider a fast charge transfer which has been observed in EIS spectra under UV for this layer (Fig. 11). Under visible light, no photo-current was detected and no charge transfer occurred which is in good agreement with EIS results shown in Fig. 11. In the case of the 64W-N-TiO<sub>2</sub> layer (Fig. 12d), the semiconducting behavior is also obvious under both UV and visible light in agreement with the EIS observations. Moreover, the generated photo-current is greater than the one in the non-doped 64 W TiO<sub>2</sub>. This shows the relevant advantage of nitrogen doping in TiO2. Epc slightly shifts to the left indicating a faster charge transfer under visible light. The conclusion is that the layers prepared at 64 W show a typical n-type semiconducting behavior and could be qualified of 'typical photo-materials' which activity is completely light-dependent.

In the case of the 100W–TiO<sub>2</sub> layers (Fig. 12b), the Ti<sup>3+</sup> [51, 52] species already exist in the material without illumination. The proof is the oxidation and reduction peaks existing in the dark. Under UV light, the photo-current

increases especially in the 0-0.2 V vs. Ag/AgCl range and the redox peaks intensity increases slightly. This explains the  $R_{ct}$  decrease in the UV displayed in Fig. 11. It could also be observed that  $R_{ct}$  decreases remarkably from 64W-TiO<sub>2</sub> to 100W-TiO<sub>2</sub>. This fact is due to the greater photo-current generated in the case of 100W-TiO<sub>2</sub> due to the species mobility. This mobility results from a combination of the initial Ti<sup>3+</sup> and the Ti<sup>3+</sup> generated by UV irradiation. Under visible light, the material behavior is almost the same as in the dark proving that the initial Ti<sup>3+</sup> does not tailor the layer band gap. The redox peaks intensities are slightly lower than the ones in the dark revealing the surface state role in trapping some mobile Ti<sup>3+</sup> decreasing by that the photo-current and increasing the  $V_{oc}$  values as reported in Fig. 9 and explained in Fig. 10. For the 100W-N-TiO<sub>2</sub> (Fig. 12d), the Ti<sup>3+</sup> species still exist intrinsically into the material as the redox peaks exist in the dark. Their concentration increases slightly under UV and visible light as the photo-current increases under irradiation. These results are in good agreement with the material EIS spectra shown in Fig. 11. Still, this increase is not really noticeable which proves the existence of an initial conductive phase for the layers deposited at 100 W. At the interface, in the electrode-electrolyte equilibrium conditions (0 V vs. Ag/AgCl), it could be noticed that a higher photo-current is measured under visible light than in the dark or UV for the 100W-N-TiO<sub>2</sub> (see the starting point of the CV curves in Fig. 12d). This reveals the nitrogen role in the band gap tailoring and in the  $R_{\rm ct}$  decrease under visible light. Thus, at a higher plasma power, the electrode contains an initial conductive phase including Ti<sup>3+</sup>. The electrode activity exists even in the dark and is barely enhanced under

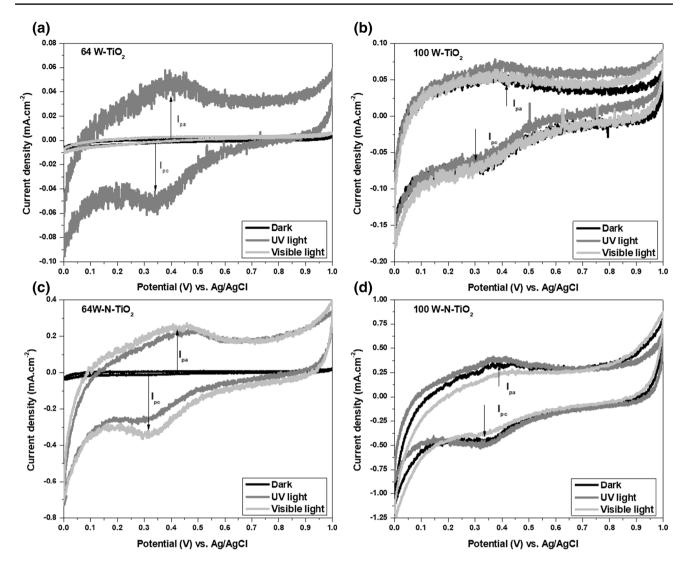


Fig. 12 CV curves at 5 mV.s<sup>-1</sup> in the dark, in UV, and in visible light for a 64W-TiO<sub>2</sub>, b 100W-TiO<sub>2</sub>, c 64W-N-TiO<sub>2</sub>, and d 100W-N-TiO<sub>2</sub>

light (in the UV for the pure  $TiO_2$  and in the visible for the N–TiO<sub>2</sub>). The layers could be qualified of 'partial photomaterials' in which carriers are created by light and easily transferred by an initially existing conductive phase.

#### 4.6 LV curves

LV has been performed for the four layers in the dark, UV, and visible light from 0 to 2 V vs. Ag/AgCl at a scan rate of  $1 \text{ mV s}^{-1}$ . The results are presented in Fig. 13.

Linear Voltammetry is a useful technique to study the oxygen evolution reaction (OER) current and the starting potential.

The photo-current is enhanced under UV light for the  $64W-TiO_2$  as observed in Fig. 13a. This result is in good agreement with the previous electrochemical observations. In the case of the 100W-TiO<sub>2</sub> (Fig. 13b), no current

variation is observed between dark and visible light. The currents are higher than in the case of  $64W-TiO_2$  as an evidence of initial conductive carriers in the material. These carriers are highly activated under UV light, their concentration increases under this light range and since the layer is initially conductive, they migrate to the electrode–electrolyte surface causing instant electrolyte oxidation (at 1.4 V vs. Ag/AgCl). At the same time, an amount of Ti<sup>3+</sup> could be oxidized to Ti<sup>4+</sup> which causes current decrease and then lowering at 2 V vs. Ag/AgCl [51, 52]. Similarly, the photo-current enhancement under visible light for the  $64W-N-TiO_2$  (Fig. 13c) and  $100W-N-TiO_2$  (Fig. 13d) is clear.

The higher current observed in the case of the  $100W-N-TiO_2$  reveals the more intrinsic conductive properties due to the initial Ti<sup>3+</sup> species.

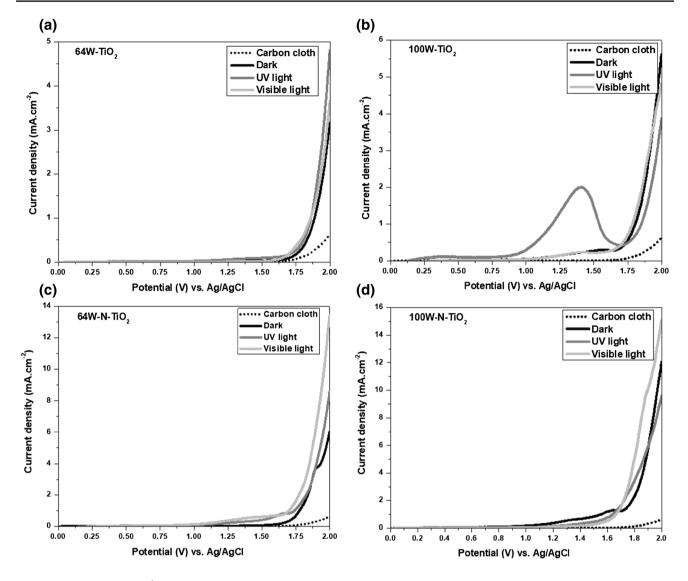


Fig. 13 LV curves at 1 mV.s<sup>-1</sup> in the dark, UV, and visible for a 64W–TiO<sub>2</sub>, b 100W–TiO<sub>2</sub>, c 64W–N–TiO<sub>2</sub>, and d 100W–N–TiO<sub>2</sub>

#### 5 Conclusions

Anatase and Nitrogen-doped anatase thin layers with thicknesses of some hundred nanometers have been grown by low-frequency PECVD process at 64 W and 100 W according to previously optimized conditions. Three different substrates have been used for the deposition of layers: silicon for XRR, XPS, and ellipsometry measurements, Nickel foil for crystal growth morphology and nitride shell observations by SEM, and conductive porous carbon (E-Tek®) for electrochemical studies. Due to its intrinsic porosity, lower layer thicknesses have been obtained on the porous carbon when compared to dense substrates. XPS has revealed a higher substitutional Ti-N incorporation into the doped layers prepared at 64 W due to the higher amount of N<sup>+</sup> species in the lower plasma power ranges as previously reported in the literature. Ellipsometry microstructure simulation has shown that the films are rough, constituted of a bulk  $TiO_2$  on top of which lies a diffusion layer. In parallel, the layer refractive index variation from the theoretical value for anatase (2.5) was more noticed at 64 W than at 100 W. This is an indication of a higher lattice modification at lower plasma power as shown by XPS. These structural differences directly related to the plasma power in the preparation of films have a direct impact on the material photo-electrochemical behavior where the layers prepared at 64 W exhibit a 'fully semiconducting' behavior under UV and visible light, whereas the films deposited at 100 W already contain a conductive phase (Ti<sup>3+</sup> species) which activity can be enhanced under light.

As perspectives, layers with higher nitrogen amount should be characterized under the same conditions in order to evaluate the effect of doping incorporation on the structural, optical, and photo-electrochemical properties of anatase PECVD materials. Then optimized N-doped films should be integrated as anodes in photo-electrochemical systems for hydrogen generation by water splitting under solar light.

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